Saoni Banerji

List of Publications by Year in descending order

Source: https://exaly.com/author-pdf/630322/publications.pdf

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| | | 1937685 | 2053705 |
|----------|----------------|--------------|----------------|
| 8 | 58 | 4 | 5 |
| papers | citations | h-index | g-index |
| | | | |
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| | | | |
| 8 | 8 | 8 | 48 |
| all docs | docs citations | times ranked | citing authors |
| | | | |

| # | Article | IF | CITATIONS |
|---|--|-----|-----------|
| 1 | Modeling and Experimental Analysis of the Mass Loading Effect on Micro-Ionic Polymer Actuators Using Step Response Identification. Journal of Microelectromechanical Systems, 2021, 30, 243-252. | 2.5 | 1 |
| 2 | Resonant MEMS Pressure Sensor in 180 nm CMOS Technology Obtained by BEOL Isotropic Etching. Sensors, 2020, 20, 6037. | 3.8 | 7 |
| 3 | A Comprehensive High-Level Model for CMOS-MEMS Resonators. IEEE Sensors Journal, 2018, 18, 2632-2640. | 4.7 | 8 |
| 4 | CMOS-MEMS resonant pressure sensors: optimization and validation through comparative analysis. Microsystem Technologies, 2017, 23, 3909-3925. | 2.0 | 10 |
| 5 | Characterization of CMOS-MEMS Resonant Pressure Sensors. IEEE Sensors Journal, 2017, 17, 6653-6661. | 4.7 | 21 |
| 6 | Temperature and pressure characterization of the quality factor in a CMOS-MEMS resonator. , 2016, , . | | 3 |
| 7 | Optimization of parameters for CMOS MEMS resonant pressure sensors. , 2015, , . | | 3 |
| 8 | CMUT ultrasonic power link front-end for wireless power transfer deep in body. , 2013, , . | | 5 |